

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 10/550,325

Applicant: JIKEN et al.

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Geald Shelit

22 December 2008 (Date)

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

## <u>AMENDMENT</u>

Sir:

The Office Action of 3 September 2008 has been carefully reviewed and the following amendments and remarks are made in response thereto.

Remarks/Arguments begin on page 2 of this paper.